

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Gurtej S. Sandhu
Serial No. : 10/765,314
Filed : January 27, 2004
Title : ATOMIC LAYER DEPOSITION WITH POINT OF USE GENERATED
REACTIVE GAS SPECIES
Docket : MIO 0092 NA
Examiner : Smith, Francis P.
Art Unit : 1792
Confirm. No. : 9407

EFS WEB ELECTRONIC SUBMISSION
September 9, 2008

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT UNDER 37 CFR 1.312

This paper is being filed to update the cross-reference data after allowance. Consideration of the present application is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

- Amendments to the Specification; and
- Remarks.